

	L #	Hits	Search Text
1	L1	190	(mask or reticle) with stage with tilt\$3
2	L2	950	(substrate or wafer or plate) with stage with tilt\$3
3	L3	168	1 and 2
4	L4	1115	(mask or reticle) near5 (deform\$3 or sag\$4)
5	L5	13	3 and 4
6	L6	31597	(measur\$5 or detect\$3 or determin\$5) near3 focus\$3
7	L7	96	3 and 6
8	L8	146	6 same ((interpolat\$3 or calculat\$3) with (image near plane))
9	L9	3	3 and 8

OK

9/16/04